

Notice of References Cited	Application/Control No. 10/785,598	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,425,675	07-2002	Onishi et al.	362/607
*	B	US-6,871,982	03-2005	Holman et al.	362/331
*	C	US-6,464,365	10-2002	Gunn et al.	362/27
*	D	US-5,839,823	11-1998	Hou et al.	362/327
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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